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Our Case No. 7103/205

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Li et al.)
Serial No. 09/938,056) Examiner: George Nguyen
Filing Date: August 23, 2001) Group Art Unit No.: 3723
For MULTI-STEP POLISHING SYSTEM)
AND PROCESS OF USING SAME)

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AMENDMENT

APR 23 2003

Commissioner for Patents
Washington, D.C. 20231

TECHNOLOGY CENTER R3700

Dear Sir:

In reply to the Office Action dated November 14, 2002, Applicants have filed this Amendment by Certificate of Mailing. Applicant respectfully requests the Examiner to withdraw the objections and rejections to this application and to grant allowance of this Application in view of the following remarks and amended claims: